Electronic Pate	nt App	lication Fee	Transm	ittal			
Application Number:	10	10536621					
Filing Date:	26-	26-May-2005					
Title of Invention:	Pol	Polishing pad and method of producing semiconductor device					
First Named Inventor/Applicant Name:	Ma	Masahiko Nakamori					
Filer:	Da	Daniel E. Altman/Hiroko Isetani					
Attorney Docket Number:	UN	UNIU40.005APC					
Filed as Large Entity	•						
U.S. National Stage under 35 USC 371 Fil	ing Fee	s					
Description		Fee Code	Quantity	Amount	Sub-Total ir USD(\$)		
Basic Filing:				1			
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
Extension-of-Time:							
Extension - 1 month with \$0 paid		1251	1	130	130		

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
	Total in USD (\$)			130